

L Number	Hits	Search Text	DB	Time stamp
1	18312	(print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:24
2	10497	((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:25
3	4261	((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:26
4	1139	(((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:26
5	714	((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:27
6	107	((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or, micrometer\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:29
7	51	(((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:39
8	35	((((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:43

9	37	(((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1 or micron\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:55
10	70	(((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) not ((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1 or micron\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 10:55
11	14	(((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) not ((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1 or micron\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 11:06

12	56	(((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) not ((((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1 or micron\$1))) not ((((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) not ((((((((((print\$4 or record\$4) and (electro-mechanical or piezoelectric\$1 or piezo-electric\$1 or pzt) and pressure) and (waveform\$1 or voltage\$1)) and (nozzle\$1 or orifice\$1)) and ((nozzle\$1 or orifice\$1) with diameter)) and (drop\$4 with (size or diameter\$1))) and ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1)) and (("5" or "20" or "25" or "40") with ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1))) and (("5" or "20" or "25" or "40") adj ((micro adj meter\$1) or micro-meter\$1 or micrometer\$1 or micron\$1))))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2002/11/04 11:06
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